07 JAN 2003



162162

METHOD OF MANUFACTURING SURFACE ACOUSTIC WAVE DEVICE

ABSTRACT OF THE DISCLOSURE

A method of manufacturing a surface acoustic wave device having a piezoelectric substrate and an interdigital transducer provided thereon, includes the steps of forming a coating layer made of inorganic material or organic material on the piezoelectric substrate so as to cover the interdigital transducer and etching the coating layer via a laser light to adjust an operation frequency of the surface acoustic wave device.

Fig. 1



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